RCEF 81

DOCKÉTNO: VSEA 26-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Serial No: Steven R. Walther

Confirmation No:

10/006,462 5689

Filed:

December 4, 2001

For:

DOSE UNIFORMITY CONTROL FOR PLASMA DOPING

SYSTEMS

Examiner:

Michelle Crowell

Art Unit:

1763

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 241 day of March, 2005.

Janine Capillas

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Sir:

Transmitted herewith are the following documents:

[X] Final Amendment

[X] Request for Continued Examination

[X] Three-month Petition for Extension of Time

[X] Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted, Steven R. Walther, Applicant

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Bv:

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